



In re Application of: Takahiro ORNAKADO
 Application No. 09/911,581
 Filed: July 25, 2001
 For: SI-MOS HIGH-FREQUENCY SEMICONDUCTOR DEVICE AND THE MANUFACTURING METHOD OF THE SAME

COMMISSIONER FOR PATENTS
 Washington, D.C. 20231

RECEIVED
 OCT 29 2002
 TECHNOLOGY CENTER 2800

Sir:

Transmitted herewith is a response to an office action in the subject application.

☐ Applicants claim small entity status of this application under 37 CFR 1.27.

☒ Petition for Extension of Time

- ☐ Applicants petition for a one-month extension of time under 37 CFR 1.136, the fee for which is \$110.00 (enclosed).
☒ Applicants believe that no petition for an extension of time is necessary. However, to the extent that such petition is deemed necessary, Applicants hereby petition for a sufficient extension of time to render the present submission timely. Please charge Deposit Account No. 12-1216 for the appropriate petition fee.

☒ No additional claim fee is required.

☐ Other:

The claim fee has been calculated as shown below:

					SMALL ENTITY		OTHER THAN A SMALL ENTITY	
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FOR	EXTRA CLAIMS PRESENT	RATE	ADDIT. CLAIM FEE	RATE	ADDIT. CLAIM FEE
TOTAL		MINUS		=	x 9=	\$	x 18=	\$
INDEPENDENT		MINUS		=	x 42=	\$	x 84=	\$
<input type="checkbox"/>	FIRST PRESENTATION OF MULTIPLE CLAIM				+ 140=	\$	+ 280=	\$
					TOTAL	\$	TOTAL	\$

☐ Please charge my Deposit Account No. 12-1216 in the amount of \$. A duplicate copy of this sheet is attached.

☐ A check in the amount of \$ is attached.

- ☒ The Commissioner is hereby authorized to charge any deficiencies in the following fees associated with this communication or credit any overpayment to Deposit Account No. 12-1216. A duplicate copy of this sheet is attached.
☒ Any filing fees under 37 CFR 1.16 for the presentation of extra claims.
☒ Any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

Jeffrey A. Wyand, Reg. No. 29,458
 LEYDIG, VOIT & MAYER
 700 Thirteenth Street, N.W., Suite 300
 Washington, DC 20005-3960
 (202) 737-6770 (telephone)
 (202) 737-6776 (facsimile)

Date:

JAW/tpn

Amendment or ROA Transmittal (Revised 9/10/02)



#7/Election
+ B

10/30/02

PATENT
Attorney Docket No. 401308/ASAHINA

males

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Takahiro OHNAKADO

Application No. 09/911,581

Art Unit: 2815

Filed: July 25, 2001

Examiner: N Drew Richards

For: SI-MOS HIGH-FREQUENCY
SEMICONDUCTOR DEVICE AND THE
MANUFACTURING METHOD OF THE
SAME

RECEIVED
OCT 29 2002
TECHNOLOGY CENTER 2800

RESPONSE TO OFFICE ACTION

Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

In response to the Office Action dated October 1, 2002, please enter the following amendments and consider the following remarks.

AMENDMENTS

IN THE TITLE:

✓
Replace the title with:

SI-MOS HIGH-FREQUENCY SEMICONDUCTOR DEVICE